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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE  
(Atty. Docket No. 100176)

First Inventor: Roland K. SEVILLA

Serial No.: 10/601,601

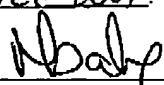
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Title: POLISHING PAD FOR  
ELECTROCHEMICAL-MECHANICAL  
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## OFFICE ACTION RESPONSE

In response to the Office Action of November 9, 2005, please enter the following remarks into the record for this application.

Remarks/Arguments begin on page 2 of this paper.

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